

<b>Notice of References Cited</b>	Application/Control No. 09/882,141	Applicant(s)/Patent Under Reexamination WANG ET AL.4
	Examiner Lynette T. Umez-Eronini	Art Unit 1765

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-4208241	06-1980	Harshabarger et al.	156/643
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
U	IBM Technical Disclosure Bulletin, MOS Gate Stack RIE With Self-Passivating Sidewalls, May 1, 1987, Vol. 29, No. 12, pp 5275-5276.
V	
W	
X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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